Effect of stress on the passivation of Si-DLC coating as stent materials in simulated body environment

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A B S T R A C T

DLC coating can be used for vascular stents to prevent the stainless steel substrate from eluting Ni and Cr by plastic deformation and corrosion environment. The stress corrosion cracking (SCC) of Si-diamond-like carbon (Si-DLC) coated on 316L stainless steel was studied in a simulated body environment of a deaerated 0.89 wt.% NaCl electrolyte at 37 °C. This paper investigated the effect of Si-DLC coating on the SCC of 316L SS by slow-strain-rate test (SSRT), constant load test (CLT), and electrochemical impedance spectroscopy (EIS). The EIS data were monitored for the elastic and plastic regions under CLT to determine the electrochemical behavior of the passive film during SCC phenomena. The Si-DLC coated steel exhibited more ductility than uncoated steel and less susceptibility to SCC in this environment. According to X-ray photoelectron spectroscopy (XPS) analysis, the film repassivation occurs due to the presence of the silicon oxide layer on the Si-DLC film surface.

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1. Introduction

Vascular stents are devices used in coronary angioplasty, a medical practice that decreases restenosis following vessel lesions [1]. The main characteristics of stents, which are made from materials able to fulfill precise mechanical properties, are the ability to expand when deployed and to preserve this expansion against the pressure exerted by the vessel wall [2]. Stents can keep blood flowing smoothly through diseased and/or damaged blood vessels during and after vascular surgery, which is a procedure that uses an inflated balloon to enlarge the vessel [3]. However, stent materials are often compromised by two adverse effects [4], corrosion and stress: (1) Corrosion is unavoidable because the body is an aqueous medium containing various ions and organic substances, forming an electrolyte solution [5–10]. These ions react electrochemically with the surface of metallic biomaterials to cause corrosion. (2) Stents are exposed to two main stresses: the first due to the contact with blood vessel and the second being the shear stress provoked by the blood flow and pressure required by stents to expand [11–16]. In the field of biomaterials, SCC is particularly insidious for biomaterials devices that are subjected to mechanical stress in a biological environment rich in chlorides [2]. To inhibit effectively the multilevel interconnection from stress-related corrosion malfunction, the SCC problem of stent materials needs to be examined. Three conditions are considered to be required simulta-
effect of stress on the passivation of Si-DLC coatings as material candidates for vascular stents.

2. Materials and methods

2.1. Materials preparation

Type 316L SS was used as the substrate material. Cylindrical specimens of the SS substrate were fabricated according to NACE standard TM 0177-96 [28], and had threaded ends with 1/4 in. diameter and 1 in. gauge length. Sample surfaces were mechanically polished down to an average roughness of $R_s = 0.1 \mu m$ using SiC paper and diamond paste. Si-DLC films were prepared by radio frequency plasma-assisted, chemical vapor deposition (RF-PACVD). The substrate was placed on the water-cooled cathode to which 13.56 MHz rf power was delivered through the impedance-matching network. Before deposition, the substrates were cleaned using argon ion for 30 min at 6 sccm, with a bias voltage of $-750 \text{Vb}$ and pressure of $3.7 \times 10^{-3} \text{Torr}$. The precursor gases used for Si-interlayer (Si buffer) and Si-DLC were silane (SiH$_4$, SiH$_4$:H$_2$ = 10:90) and a mixture of C$_6$H$_6$ and silane, respectively. The vacuum vessel was pumped to a base pressure of $3 \times 10^{-2} \text{Torr}$. An approximately $0.01$-thick Si interlayer was deposited onto the substrate, and then Si-DLC films of a $1 \mu m$-thick were deposited with a mixture gases of C$_6$H$_6$ ($3.2 \text{sccm}$) and silane ($3 \text{sccm}$) at $-400 \text{Vb}$ and a pressure of $10 \times 10^{-3} \text{Torr}$. An approximately 0.01-μm-thick Si interlayer was deposited onto the substrate, and then Si-DLC films of a 1-μm-thick were deposited with a mixture gases of C$_6$H$_6$ (3.2 sccm) and silane (3 sccm) at $-400 \text{Vb}$ and a pressure of $10 \times 10^{-3} \text{Torr}$.

2.2. Slow-strain-rate test (SSRT)

The specimen for the slow-strain-rate test (SSRT) was coated with an insulating lacquer to give an identical, exposed surface area. The substrate area was 5.12 cm$^2$. The reference and counter electrodes were saturated calomel and pure graphite electrodes, respectively. Potentiodynamic test was conducted using an EG&G PAR 263 A for DC measurement. The EIS tests were conducted using a Zahner IM6e system with a commercial software program for the AC measurements. The amplitude of the sinusoidal perturbation was 20 mV. The frequency range was from 100 kHz to 1 mHz.

2.3. Constant load test (CLT)

The SCC test was performed using proof ring tester. From the SSRT stress–strain curve, we determined the load needed to deflect the ring to the desired value. The loads were transferred to the deflection to apply to the proof ring. CLT was conducted at freely-corroding, open-circuit potentials. During the deflection application, EIS test measurements were taken every 12 h up to 3 days.

2.4. Electrochemical measurements

All experiments were performed at 37 °C in 0.89 wt.% NaCl made with distilled water. The solution was thoroughly deaerated by bubbling high purity nitrogen gas for 2 h prior to specimen immersion and were continuously purged during the test. The exposed coating area was 5.12 cm$^2$. The reference and counter electrodes were saturated calomel and pure graphite electrodes, respectively. Potentiodynamic test was conducted using an EG&G PAR 263 A for DC measurement. The EIS tests were conducted using a Zahner IM6e system with a commercial software program for the AC measurements. The amplitude of the sinusoidal perturbation was 20 mV. The frequency range was from 100 kHz to 1 mHz.

2.5. Coating analysis

After the constant load tests were completed, scanning electron microscopy (SEM) and X-ray photoelectron spectroscopy (XPS) were used to examine the surface of the specimens.

3. Results and discussion

In Fig. 1, the stress–strain–time curves of the Si-DLC and 316L SS specimens in the simulated body environment showed somewhat different behavior. The SSRT results for specimens are also given in Table 2. The polarization curves for Si-DLC coated on 316L SS and 316L SS substrate in 0.89 wt.% NaCl electrolyte deaerated by bubbling high purity nitrogen gas at 37 °C were monitored continuously until fracture occurred. The load was applied at a constant strain rate of $10^{-6} \text{s}^{-1}$. SSRT was conducted at freely-corroding, open-circuit potentials.

Table 2

<table>
<thead>
<tr>
<th>Condition</th>
<th>Load (kgf)</th>
<th>Deflection (mm)</th>
</tr>
</thead>
<tbody>
<tr>
<td>Elastic region</td>
<td>60</td>
<td>$63.5 \times 10^{-3}$</td>
</tr>
<tr>
<td>Plastic region</td>
<td>147</td>
<td>$152.4 \times 10^{-3}$</td>
</tr>
</tbody>
</table>

Table 1

<table>
<thead>
<tr>
<th>Specimen</th>
<th>Time to fracture (day)</th>
<th>Elongation (%)</th>
<th>Yield stress (kgf/mm$^2$)</th>
<th>Fracture stress (kgf/mm$^2$)</th>
</tr>
</thead>
<tbody>
<tr>
<td>316L SS</td>
<td>9.99853</td>
<td>33.998</td>
<td>3.291</td>
<td>2.2578</td>
</tr>
<tr>
<td>Si-DLC</td>
<td>10.62175</td>
<td>36.128</td>
<td>3.504</td>
<td>2.4672</td>
</tr>
</tbody>
</table>

Fig. 2. Polarization curves for Si-DLC coated on 316L SS and 316L SS substrate in 0.89 wt.% NaCl electrolyte deaerated by bubbling high purity nitrogen gas at 37 °C.
Table 1. The difference between Si-DLC and 316L SS specimens clearly reflected reduction in elongation caused by the SCC process. The total strain of the Si-DLC specimen was 36%, compared to 34% for the substrate specimen, indicating more ductility of the Si-DLC coated steel compared to 316L SS substrate. This result was used to determine the necessary loads to calculate the deflected proof ring for CLT. As reference information about SSRT in Table 2, elastic loads were selected as 60, 100 kgf and plastic load was 147 kgf.

Potentiodynamic polarization curves for Si-DLC film and substrate are shown in Fig. 2. From polarization test results, \( P_i(\%) \), the protective efficiency of the film, can be calculated by the following equation:

\[
P_i(\%) = \left[ 1 - \frac{I_{corr}}{I_{corr0}} \right] \times 100
\]

where \( I_{corr} \) and \( I_{corr0} \) indicate the corrosion current density of the film and substrate, respectively [29]. The measured corrosion potential \( E_{corr} \), corrosion current density \( I_{corr} \), and protective efficiency \( P_i \) are given in Table 3. The Si-DLC film was well passivated, with low passive current density and wide passive potential range. The high protective efficiency is closely related to the corrosion protection ability and durability of coating in 0.89 wt.% NaCl solution.

Figs. 3 and 4 show Nyquist plots of the 316L SS and Si–DLC coated steel electrodes under stressed and unstressed conditions for 72 h. The EIS data for 316L SS substrate specimens among unstressed, elastic and plastic conditions were very different. However, the difference between elastic and plastic of Si-DLC specimens was not significant. The semicircle depression in the Nyquist diagram was attributed to the heterogeneity of the surface due to the stress effect. Most impedance data for Si-DLC films in corrosive media agreed with the equivalent circuit shown in Fig. 5, where \( R_s \) represents the solution resistance, and \( R_p \) the polarization resistance. In this case, the capacitor was replaced with a CPE to improve the fitting quality where CPE contained a double-layer capacitance \( C \) and phenomenological coefficient \( n \). The \( n \) value of a CPE indicates its meaning: \( n = 1 \), a capacitance; \( n = 0.5 \), a Warburg impedance; \( n = 0 \), a resistance and \( n = -1 \), an inductance [30]. In the present study, \( n \) was consistently maintained near 0.9, as a result of the deviation from ideal dielectric behavior which arose due to the heterogeneity of the surface both laterally and within the depth of the oxide film, which reflects the properties of the double layer.

Table 3
Results of potentiodynamic polarization tests.

<table>
<thead>
<tr>
<th>Specimen</th>
<th>( E_{corr} ) (mV)</th>
<th>( I_{corr} ) (nA/cm²)</th>
<th>( P_i ) (%)</th>
</tr>
</thead>
<tbody>
<tr>
<td>Substrate</td>
<td>-223.46</td>
<td>120.20</td>
<td>-</td>
</tr>
<tr>
<td>Si-DLC</td>
<td>-215.63</td>
<td>1.56</td>
<td>98.79</td>
</tr>
</tbody>
</table>

Fig. 3. Nyquist plots for 316L stainless steel specimens in simulated body environment: (a) unstressed condition; (b) and (c) elastic regions at 0.0025 and 0.0040 in., respectively; and (d) plastic region at 0.0060 in.
In Fig. 6, the coatings in all cases exhibited high polarization resistances (>10^6 Ω·cm²) during the immersion time, thereby indicating the low corrosion rates [31]. The absolute value of the impedance of substrate was clearly lower than those of coating. The initial increase in polarization resistance of Si-DLC coated steel under plastic stress might have been caused by the spontaneous passivity ability of the coating. It appears that film formation during electrolyte immersion maintained the high polarization resistance for both elastic and plastic regions. Even though the stress at plastic condition became more severe, the R_p was stable at high value. It reveals that the Si-DLC coating under plastic condition had high performance because of the enrichment of passive film.

It was found that the Si-DLC coating reduced the susceptibility of type 316L SS to SCC in the simulated body environment. The remarkable decrease of the polarization resistance of 316L SS substrate that occurred under different stressed conditions indicates that the susceptibility of 316L steel to SCC increased with an increase of the applied stress. However, no significant differences were observed in the polarization resistance of Si-DLC coated steel under stressed conditions. Therefore, the Si-DLC coated steel is less susceptible to SCC in this environment. EIS results indicate that the passive layer on the Si-DLC coating remained intact under stressed conditions. The applied stress appeared to have a
negligible effect on the protective nature of the surface film. Although the plastic deformation ruptures the passive film, the rate of repassivation is as high as the rate of breakdown of passive film. The schematic figure of repassivation mechanism is given in Fig. 7. A model for the mechanism of the stressed damage of the DLC film can be described with the following three processes: (1) The first step is the formation of the passive film in 0.89 wt.% NaCl solution. (2) When the stress is applied to the specimen, the stress opened the film in front of its face with the initial breakdown of passive film on Si-DLC film. It exceeds the critical stress that the film could be broken down, so as to release the stresses. (3) As soon as passive film was broken down, repassivation would be initiated due to the Si, which promotes repassivation of DLC film [26,27].

Surface films were evaluated by XPS measurement, with all results confirming the presence of silicon oxide in the Si-DLC surface after CLT (Fig. 8). However, it should be noted that the XPS analysis focused only on the surface data for the silicon oxide layer. The peaks at binding
energies of 100.477, 101.973, and 103.407 eV represented SiO\(_x\) [32,33] and those of 102.387, 102.419, and 102.494 eV represented Si–C–O compound [34,35]. The composition of the top layer of the oxide film, as estimated by quantitative analysis in Table 4, was Si–C–O compound formed from silicon during the stress application. In addition, this figure also shows that the silicon oxide containing Si–C–O compound was enriched with the applied load due to the silicon migration outwards through the passive film.

The surface after CLT was examined by SEM. Fig. 9 shows numerous coating cracks on the specimen surface with vertical crack growth parallel in the film and rising density with increasing stress. It is noteworthy that the absence of any pitting between the cracks indicated repassivation and film growth.

4. Conclusions

1. The SSRT confirmed the higher ductility of the Si-DLC coated steel compared to uncoated steel. The Si-DLC coated steel is less susceptible to SCC than 316L SS.
2. The Si-DLC coating under the plastic load had much higher polarization resistance than 316L SS, i.e., the applied plastic stress did not appear to influence the protective nature of the film.
3. The XPS test results showed that the Si-DLC films improved the corrosion resistance of steel under the stressed condition due to the presence of the silicon oxide layer on the Si-DLC film.

### Table 4
Quantitative analysis of Si 2p obtained by XPS after test.

<table>
<thead>
<tr>
<th>Load</th>
<th>Name</th>
<th>Concentration (%)</th>
<th>Area</th>
<th>Position</th>
<th>Height</th>
</tr>
</thead>
<tbody>
<tr>
<td>Unload</td>
<td>Si 2p/2 (SiO(_x))</td>
<td>1.201</td>
<td>1547.267</td>
<td>100.477</td>
<td>937.779</td>
</tr>
<tr>
<td></td>
<td>Si 2p/2 (SiO(_2))</td>
<td>0.527</td>
<td>679.379</td>
<td>101.973</td>
<td>40.568</td>
</tr>
<tr>
<td></td>
<td>Si 2p/2 (SiO(_x))</td>
<td>0.234</td>
<td>288.087</td>
<td>103.407</td>
<td>127.351</td>
</tr>
<tr>
<td>60 kgf</td>
<td>Si 2p/2 (C(_6)H(_5))Si (C(_6)H(_5))(_3)</td>
<td>1.400</td>
<td>2561.758</td>
<td>100.678</td>
<td>1456.962</td>
</tr>
<tr>
<td></td>
<td>Si 2p/2 (Si–C–O compound)</td>
<td>0.545</td>
<td>997.195</td>
<td>102.494</td>
<td>484.636</td>
</tr>
<tr>
<td>100 kgf</td>
<td>Si 2p/2 (C(_6)H(_5))Si (C(_6)H(_5))(_3)</td>
<td>1.486</td>
<td>2519.487</td>
<td>100.650</td>
<td>1409.378</td>
</tr>
<tr>
<td></td>
<td>Si 2p/2 (Si–C–O compound)</td>
<td>0.723</td>
<td>1225.307</td>
<td>102.419</td>
<td>595.499</td>
</tr>
<tr>
<td>147 kgf</td>
<td>Si 2p/2 (C(_6)H(_5))Si (C(_6)H(_5))(_3)</td>
<td>1.923</td>
<td>3495.648</td>
<td>100.694</td>
<td>1989.930</td>
</tr>
<tr>
<td></td>
<td>Si 2p/2 (Si–C–O compound)</td>
<td>0.877</td>
<td>1593.551</td>
<td>102.387</td>
<td>774.465</td>
</tr>
</tbody>
</table>

4. From the typical SEM images after CLT, the surface of Si-DLC coated steel showed no active path at the cracks, indicating repassivation of the film.

References